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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Kozo SHIMIZU et al.**

Group Art Unit: **2812**

Serial No.: **10/771,391**

Examiner: **Lynne A. Gurley**

Filed: **February 5, 2004**

Confirmation No.: **3325**

For: **METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE**

Attorney Docket Number: **042080**

Customer Number: **38834**

AMENDMENT UNDER 37 CFR § 1.111

Mail Stop Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, Virginia 22313-1450

November 2, 2004

Sir:

In response to the Office Action dated August 10, 2004, Applicants amend the above-identified application as follows and submit the following remarks.

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Amendments to the Drawings begin on page 5 of this paper.

Remarks/Arguments begin on page 6 of this paper.